

PATENT NUMBER and ISSUE DATE

U.S. UTILITY Patent Application

APPL NUM	NUM FILING DATE CLASS SUBCLASS GAU EXAMINE				INER	\neg				
10052407	01/18/2002	216	12	1746	SHA	MIM	AHME			
**APPLICANT	S: Tanaka	Tomoki;	Toda Risaku;	1	-					
**CONTINUING DATA VERIFIED: THIS APPLICATION IS A CIP OF 09/688,722 10/16/2000 , PAT 6,494,135 SA WHICH IS A CIP OF 09/483,640 01/14/2000 PAT 6,197,610										
** FOREIGN APPLICATIONS VERIFIED:										
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Foreign priority cla 35 USC 119 condit Verified and Ackno		D yes	i ⊅ no i □ no		ATTO: 22397	RNEY DO .305	CKET NO			
TITLE: Method and system for making a micromachine device with a gas permeable enclosure U.S.DEPT. OF COMMUPAT. 8 TM-PTO-438L(Rev. 12-94)										
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NOTICE OF ALLOWANCE MAILED			CLAIMS ALLOWED						
		Assistant Examiner	Total Claims		Print Claim for O.G				
ISSUE FEE			DRAWING						
Amount Due	Date Paid		Sheets Drwg.	Figs.Dr	Wg.	Print Fig.			
	<u> </u>	Primary Examiner							
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TERMINAL		PREPARED FOR ISSUE	Application Examiner						
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